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AF*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor: Jeffrey W. Carr

Appln. No.: 10/002,483

Confirm. No.: 2209

Filed: November 1, 2001

Title: METHOD FOR ATMOSPHERIC PRESSURE REACTIVE
ATOM PLASMA PROCESSING FOR SURFACE
MODIFICATION

PATENT APPLICATION

Art Unit: 1763

Examiner: Allan W. Olsen

Customer No. 23910

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

mw (Signature)
Mathew Otts
Signature Date: 2/11/2005

*Entered with RCE 9/19/05
mw 9/24/05*

RESPONSE B TO OFFICE ACTION UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This RESPONSE C is in reply to the final Office Action dated January 12, 2005. No fee is believed due.

Amendments

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of the claims which begins on

Page 2 of this paper.

Remarks begin on Page 12 of this paper.